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CERTIFICATION OF MAILING OR FAX TRANSMISSION

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By: Honghong Chen

Date: April 26, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/631,384 Confirmation No. 9553  
Applicant : Werner Plass et al.  
Filed : July 31, 2003  
TC/A.U. : 2826  
Examiner : Ahmed N. Sefer  
Title : Surface Emitting Semiconductor Laser Chip and  
Method for Producing the Chip  
  
Docket No. : P2002,0637  
Customer No. : 24131

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Hon. Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE under 37 C.F.R. § 1.116**

S i r :

In response to the final Office action dated January 26, 2005 and in consideration of the Advisory action dated April 11, 2005, please consider the following:

**Remarks/Arguments** begin on page 2 of this paper.

An **Appendix** including a concise explanation of the relevance of the document "Optoelektronik I," the attorney's letter of **May 28, 2002** and the inventor's answer of **July 22, 2002** as well as a certified English translation of the priority German application DE 102 34 976.2 is attached following page 10 of this paper.